

**RECEIVED
CENTRAL FAX CENTER**

DEC 20 2004

8270 Greensboro Drive, Suite 630
McLean, VA 22102

Telephone 202.822.4554

Facsimile 202.478.1771

Fax

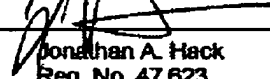
To:	United States Patent and Trademark Office	From:	Jonathan A. Hack
Fax:	703.872.9306	Pages:	11 (including cover sheet)
Phone:		Date:	December 20, 2004
Re:	U.S. Application No.: 10/085,753	CC:	

U.S. Patent Application No. 10/085,753
Filed: February 28, 2002
Title: METHOD AND DEVICE FOR REMOVING PARTICLES ON SEMICONDUCTOR WAFERS

CERTIFICATE OF TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following is being transmitted by facsimile to the U.S. Patent and Trademark Office (facsimile No. 703.872.9306) on December 20, 2004:

1. Petition For Three Month Extension of Time (1 page)
2. Amendment in response to the Office Action dated June 18, 2004 (9 pages)

By: 
Jonathan A. Hack
Reg. No. 47,623

**RECEIVED
CENTRAL FAX CENTER**

DEC 20 2004

**PATENT
Attorney Docket No. TI-31620
Application No.: 10/085,753
Customer No.: 23494**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
 TSUGA et al.) Group Art Unit: 1746
)
 Application No.: 10/085,753) Examiner: Michael Komakov
)
 Filed: February 28, 2002)
)
 For: **METHOD AND DEVICE FOR**)
 REMOVING PARTICLES ON)
 SEMICONDUCTOR WAFERS)

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated June 18, 2004, the period for reply having been extended for three months, December 18 being a Saturday, by a request for extension of time filed concurrently herewith, please amend the application as follows:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.